

## **Application Data Sheet**

### **Application Information**

Filing Date:: 10/2/2003 12:00:00AM  
Application Type:: Regular  
Subject Matter:: Utility  
CD\_ROM or CD-R?: None  
Title:: EXPOSURE APPARATUS, MAINTENANCE  
METHOD THEREFOR, SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD, AND  
SEMICONDUCTOR MANUFACTURING FACTORY  
Attorney Docket Number:: 00862.022227.1  
Total Drawing Sheets:: 15  
Small Entity?: No  
Secrecy Order in Parent Appl.?: No

### **Applicant Information**

Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Hiroshi  
Family Name:: KUROSAWA  
City of Residence:: Chiba  
Country of Residence:: Japan

### **Correspondence Information**

Correspondence Customer Number:: 5514

### **Representative Information**

Representative Customer Number::	05514
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**Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Division of	09/858,964	05/17/2001

**Foreign Priority Information**

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	148831/2000 (Pat.)	05/19/2000	Yes

**Assignee Information**

Assignee name:: CANON KABUSHIKI KAISHA  
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City of mailing Address:: Tokyo  
Country of mailing address:: Japan